| | Application No. | Applicant(s) | | |
|--|---|----------------------------------|--|--|
| Notice of Allowshills. | 10/776,215 | YUGAMI ET AL. | | |
| Notice of Allowability | Examiner | Art Unit | | |
| | Scott B. Geyer | 2829 | | |
| The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308. | | | | |
| 1. X This communication is responsive to papers filed 2-12-04. | | | | |
| 2. The allowed claim(s) is/are <u>9-20</u> . | | | | |
| 3. The drawings filed on 12 February 2004 are accepted by the Examiner. | | | | |
| 4. | | | | |
| Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/O Paper No./Mail Date 0204 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material | 5. Notice of Informal P 6. Interview Summary Paper No./Mail Dat 7. Examiner's Amendr 8. Examiner's Stateme 9. Other | (PTO-413), te nent/Comment | | |

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DETAILED ACTION

Priority

Acknowledgment is made of applicant's claim for foreign priority under 35
 U.S.C. 119(a)-(d). The certified copy has been filed in parent Application No.
 10/005,355, filed on December 7th, 2001.

Information Disclosure Statement

2. The references cited within the IDS document, received on February 12th, 2004, have been considered.

Drawings / Specification

3. The drawings and specification filed on February 12th, 2004 are acceptable.

EXAMINER'S AMENDMENT

4. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

Change the title to the following:

- - METHOD OF MAKING A MISFET SEMICONDUCTOR DEVICE HAVING A
HIGH DIELECTRIC CONSTANT INSULATING FILM WITH TAPERED END
PORTIONS - -

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Allowable Subject Matter

5. Claims 9-20 are allowed.

- 6. The following is an examiner's statement of reasons for allowance: the prior art of record and to the examiner's knowledge does not teach or render obvious, at least to the skilled artisan, the instant invention regarding the method of making a semiconductor device characterized by the steps of forming a gate electrode over an insulating film, etching the insulating film such that the insulating film end portions are recessed inwardly under the gate electrode, implanting dopants to form source and drain regions, as recited in each of independent claims 9 and 17. Claims 10-16 are dependent upon claim 9; claims 18-20 are dependent upon claim 17.
- 7. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

8. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Scott B. Geyer whose telephone number is (571) 272-1958. The examiner can normally be reached on weekdays, between 10:00am - 6:30pm. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Kamand Cuneo can be reached on (571) 272-1957. The fax phone number for the organization where this application or proceeding is assigned is

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703-872-9306. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for

published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR only.

For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

you have questions on access to the Private PAIR system, contact the Electronic

Business Center (EBC) at 866-217-9197 (toll-free).

SBG 7/20/04

SBG July 20, 2004 Much Tang Primary Examiner A.U. 2829

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